



UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of

FAI ET AL.

Serial No. 09 888,494

Filed June 26, 2001

Corres. and Mail
BOX AFRESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE

Group Art Unit: 2814

Examiner: Long Pham

For METHOD FOR FORMING A METAL OXIDE SEMICONDUCTOR TYPE FIELD EFFECT TRANSISTOR

BOX AFTHE COMMISSIONER OF PATENTS AND TRADEMARKS
Washington, D. C. 20231

Dear Sir:

Transmitted herewith is an Amendment in the above identified application.

☒ No additional fee is required.☐ Also attached:

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	18	20	0	x \$18	
Independent Claims	2	3	0	x \$84 =	
If multiple claims newly presented, add \$280.00					
Fee for extension of time					
TOTAL FEE DUE					-00-

☐ A check in the amount of \$ is attached.☒ The Commissioner is hereby authorized to charge payment of any additional fees associated with this communication or credit any overpayment, to Deposit Account No. 07-1337, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

LOWE HAUPTMAN GILMAN & BERNER, LLP

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